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-116	Silicon Processing for the Press, Sunset Beach CA	ne VLSI Era, S. WO , USA 1986 - Pgs. 1	LF and R. N. TAUBER, Lattice 179 - 181.			
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	al if citation considered, whether clude copy of this form with next		formance with MPEP Section 609;	Draw line throu	gh citation if not	in conformance and
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